



UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/629,011
Filing Date July 28, 2003
Confirmation No. 7625
Inventor Trung Tri Doan et al.
Assignee Micron Technology, Inc.
Group Art Unit 2812
Examiner Jennifer M. Kennedy
Attorney's Docket No. MI22-2359
Customer No. 021567
Title Atomic Layer Deposition Methods

RESPONSE TO NOVEMBER 29, 2005 NOTICE OF ALLOWANCE
PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING

To: Mail Stop RCE
Commissioner for Patents
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Alexandria, VA 22313-1450

VIA U.S. EXPRESS MAIL

From: Mark S. Matkin (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
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Spokane, WA 99201-3828

Responsive to the Notice of Allowance dated November 29, 2005,
Applicant amends and remarks as follows:

AMENDMENTS